

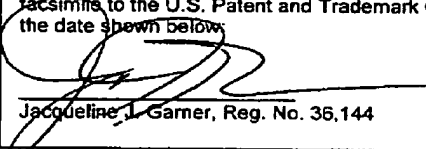
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Appl. No.: 09/921,364 Confirmation No. 6223  
Applicant: Lucius M. Sherwin TC/A.U.: 2877  
Filed: 8/2/2001 Examiner: Khaled Brown  
Docket No.: TI-30661 Customer No.: 23494  
Title: A PARTICLE DETECTION AND REMOVAL APPRATUS FOR USE ON  
WAFER FABRICATION EQUIPMENT TO LOWER TOOL RELATED DEFECTS  
FROM PARTICLE CONTAMINATION

**REQUEST FOR EXTENSION OF TIME**

Commissioner of Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATION OF FACSIMILE TRANSMISSION	
I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at 703-872-9306 on the date shown below.	
 Jacqueline J. Garner, Reg. No. 36,144	January 7, 2004 Date

Pursuant to 37 CFR 1.136(a), Applicant(s) respectfully petitions the Commissioner for an extension of the shortened statutory period for response in the above-identified Application.

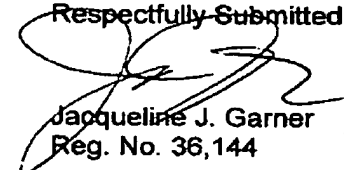
The fee for this extension is indicated below:

- ☐ One Month (\$110)  
☐ Two Months (\$420)  
☒ Three Months (\$950)  
☐ Four Months (\$1,480)

Please charge the fee to deposit account no. 20-0668. Any further necessary extension of time is hereby requested. Charge any and all fees to deposit account no. 20-0668. An original and two copies of this sheet are enclosed.

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Respectfully Submitted,

  
Jacqueline J. Garner  
Reg. No. 36,144